

(Use several sheets if necessary)

Docket number (Optional)	Application Number 10/054,735			
15689.89				
Applicant(s)				
Kaori Nakamura, et al.				
Filing Date	Group Art Unit			
11/13/2001	2681			

U.S. PATENT DOCUMENTS								
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	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	YES	NO
HN	1	2000-261849	09/22/2000	Japan	H04Q7	34	X	
HN	2	10-042350	02/13/1998	Japan	H04Q7	34	X	
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EXAMINER	EXAMINER /Huy Nguyen/			DATE CONSIDERED	08/23/2006			
EXAMINER: In not considered.	nitial if cit	tation considered, whether or not ci opy of this form with next commun	itation is in confor	mance with MPEP Section 60	9; Draw line th	rough citation if	not in confo	rmance and

INFORMATION DISCLOSURE CITATION

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*Examiner Initial	OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)				
HN	3	Official Notice of Rejection;	Case No.: DCMH120305, Patent A	Application No.: 2000-347125	
EXAMINER	/H	uy Nguyen/	DATE CONSIDERED	08/23/2006	
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